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CONFIRMATION NO. 3841

SERIAL NUMBER 10/586,400	FILING or 371(c) DATE 04/20/2007 RULE	CLASS 118	GROUP ART UNIT 1712	ATTORNEY DOCKET NO. 520514.00039		
APPLICANTS Hiroki Nakamura, Chiba, JAPAN; Toshinori Takagi, Kyoto, JAPAN; ** CONTINUING DATA ***** This application is a 371 of PCT/JP05/01174 01/21/2005 ** FOREIGN APPLICATIONS ***** JAPAN 2004-014341 01/22/2004 ** IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 08/28/2007						
Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No 35 USC 119(a-d) conditions met <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No Verified and Acknowledged <u>/KEATH T CHEN/</u> Examiner's Signature		<input type="checkbox"/> Met after Allowance Initials	STATE OR COUNTRY JAPAN	SHEETS DRAWINGS 8	TOTAL CLAIMS 16	INDEPENDENT CLAIMS 2
ADDRESS Quarles & Brady 411 E. Wisconsin Avenue Milwaukee, WI 53202 UNITED STATES						
TITLE Vacuum Deposition Method and Sealed-Type Evaporation Source Apparatus for Vacuum Deposition						
FILING FEE RECEIVED 1030	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit			